

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 8728**
Norio KIMURA et al. : Attorney Docket No. 2000_1761A
Serial No. 09/742,386 : Group Art Unit 1792
Filed December 22, 2000 : Examiner Karla A. Moore
APPARATUS AND METHOD FOR : **Mail Stop: RCE**
PROCESSING SEMICONDUCTOR
SUBSTRATE

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action of February 20, 2009, kindly amend the above-referenced U.S. patent application as follows: